

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Jugo Mitomo

Serial No.: not yet assigned

Filed: August 22, 2001

For: SEMICONDUCTOR LASER AND
METHOD OF PRODUCTION THEREOF

Case No.: 9792909-5153

Group Art Unit: not yet assigned

Examiner: not yet assigned

Date: August 22, 2001

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PRELIMINARY AMENDMENT ACCOMPANYING APPLICATION

Box Patent Application
Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Between the title and the heading "Background of Invention" on page 1, insert
the following:

--RELATED APPLICATION DATA

The present invention claims priority to Japanese Application No. P2000-
258139, filed August 23, 2000, which application is incorporated herein by reference
to the extent permitted by law.--

Respectfully submitted,

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